Search Notes				

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/802,734	BEHFAR ET AL.	EHFAR ET AL.	
Examiner	Art Unit	rt Unit	
Jim Vannucci	2828	328	

SEARCHED			
Subclass	Date	Examiner	
_			
	<u> </u>		

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
	1				
	<u>_</u>				

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
etched gap, dbr, laser, facet	1/3/2005	JV